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I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as First Class Mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on the date shown below.

Docket No.: 29926/39496

(PATENT)

Muhburut Signature: James P. Zéllér

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

re Patent Application of:

Hyug-Jin Kwon

Application No.: 10/615,062

Confirmation No.: 8080

Filed: July 8, 2003

Art Unit: 1763

For: BATCH TYPE ATOMIC LAYER

Examiner: S. MacArthur

DEPOSITION APPARATUS AND IN-SITU

CLEANING METHOD THEREOF

## **RESPONSE TO OFFICIAL ACTION**

MS Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Dear Sir:

In response to the official action dated December 30, 2005, for the above-identified U.S. patent application, please consider the following **Remarks**, which begin on page 2 of this paper.